JAP20 Rec'd PCT/PTO 0 2548 GR 2006 AU: 1621 Receipt date: 08/02/2006 Attorney Docket No.: THE VADORA BLASE INFORMATION DISCLOSURE CITATION 8007-1114 IN AN APPLICATION Applicant Hiroki SATO et al. (Use several sheets if necessary) Filing Date: Group Art Unit: August 2, 2006 U.S. PATENT DOCUMENTS 1 Class Subclass Filing date Document Number Name Evaminer (if appropriate) Initial FOREIGN PATENT DOCUMENTS Country Class Subclass Translation Date Examiner Document Number Initial Yes No OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.) MEHROTA, Ram C. et al., Aminoalkoxysilanes I. Amino derivatives of alkoxy-and alkylalkoxysilanes, Journal of Organometallic Chemistry, 1970, 24(3), 611-621 ABBOTT, A. Doyle et al., Silicate esters and related compounds, Journal of Chemical and Engineering Data, 1961, 6, 437-442 SONG, Moon-Kyun et al., Direct liquid injection metal-organic chemical vapor deposition of Hf02 thin films using Hf (dimethylaminoethoxide)4, Thin Solid Films, 2004, 450(2). 272-275

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

**EXAMINER**:

/Toby Hain/

Idw Y&T November 21, 2005

DATE CONSIDERED

09/29/2009

<sup>\*</sup> English language abstract provided for the Examiner's convenience